

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to:

Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

On

JANUARY 21, 2005

TOWNSEND and TOWNSEND and CREW LLP

By:

Eleanor J. Taylor

**AMENDMENT UNDER 37 CFR 1.116  
EXPEDITED PROCEDURE –  
EXAMINING GROUP 2812**

PATENT

Attorney Docket No.: 016301-045600US

AMAT No.: 6381 DSM/PMD/JW

Client Ref. No.: A6381/T45600

Corres and mail  
BOX AF

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of:

ZHENG YUAN et al.

Application No.: 10/090,103

Filed: February 27, 2002

For: PROCESS FOR FORMING  
SILICON OXIDE MATERIAL

Confirmation No. 4419

Examiner: Ron Everett Pompey

Technology Center/Art Unit: 2812

**AMENDMENT UNDER 37 CFR 1.116  
EXPEDITED PROCEDURE EXAMINING  
GROUP 2812**

**Mail Stop AF**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

In response to the Final Office Action mailed on the above-referenced application, please enter the following amendments and remarks. A petition for a one month extension of time for consideration of this amendment is included herein.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks/Arguments** begin on page 4 of this paper.